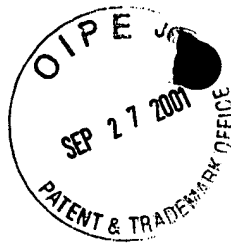


862.C2205



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
YOSHIYUKI NAGAI, et al.)
Application No.: 09/839,139)
Filed: April 23, 2001)
For: LASER OSCILLATION APPARATUS,)
EXPOSURE APPARATUS, SEMI-)
CONDUCTOR MANUFACTURING)
METHOD, SEMICONDUCTOR)
MANUFACTURING FACTORY, AND)
EXPOSURE APPARATUS)
MAINTENANCE METHOD)

Examiner: Not Assigned
Group Art Unit: 2881
September 27, 2001

RECEIVED
OCT 15 2001
TC 2800 MAIL ROOM

The Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application in which the following is incorrect:

The first-named inventor of the application incorrectly reads "Yashiyuki Nagai" and should read --Yoshiyuki Nagai--.

Applicants request issuance of a corrected Filing Receipt, corrected as shown above.

The Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for this correction. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Steven E. Warner

Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
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New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW\kjs

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UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 1616

SERIAL NUMBER 09/839,139	FILING DATE 04/23/2001 RULE	CLASS 372	GROUP ART UNIT 2881	ATTORNEY DOCKET NO. 862.C2205
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APPLICANTS

Yoshiyuki Nagai, Tochigi, JAPAN;
Naoto Sano, Tochigi, JAPAN;

** CONTINUING DATA ***** *NONE M.C.L.*

** FOREIGN APPLICATIONS ***** *YES M.C.L.*
JAPAN 2000-126502 04/26/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 06/13/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 6
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>W. S. Sano</i> Examiner's Signature Initials				

ADDRESS

05514

TITLE

Laser oscillation apparatus, exposure apparatus, semiconductor device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method

FILING FEE RECEIVED 1022	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees (Filing)
		<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
		<input type="checkbox"/> 1.18 Fees (Issue)
		<input type="checkbox"/> Other _____
		<input type="checkbox"/> Credit